



## Search History

DATE: Friday, September 10, 2004

<u>Set Name</u> side by side	<u>Query</u>	<u>Hit Count</u>	<u>Set Name</u> result set
	<i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ</i>		
<u>L8</u>	L7 and @pd<20011022	11	<u>L8</u>
<u>L7</u>	I5 and L6	29	<u>L7</u>
<u>L6</u>	etch stop	15224	<u>L6</u>
<u>L5</u>	I1 and I2 and I3 and L4	97	<u>L5</u>
<u>L4</u>	vertical etch or vertical etching	1572	<u>L4</u>
<u>L3</u>	sidewall	281774	<u>L3</u>
<u>L2</u>	pedestal	86375	<u>L2</u>
<u>L1</u>	(semiconductor or wafer or silicon)	2087371	<u>L1</u>

END OF SEARCH HISTORY

9/10/04

Craig A. Thompson